

APR 20 2000

020732-110.694 (7493)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

<b>In re United States Patent Application of:</b>	<b>Docket No.:</b>	<b>020732-110.694</b>	
<b>Applicant:</b>	<b>KORZENSKI, Michael B., et al.</b>	<b>Examiner:</b>	<b>AHMED, Shamim</b>
<b>Application No.:</b>	<b>10/807,858</b>	<b>Art Unit:</b>	<b>1765</b>
<b>Date Filed:</b>	<b>March 24, 2004</b>	<b>Confirm. No.:</b>	<b>5492</b>
<b>Title:</b>	<b>COMPOSITION USEFUL FOR          REMOVAL OF BOTTOM          ANTI-REFLECTION          COATINGS FROM          PATTERNED ION-          IMPLANTED PHOTORESIST          WAFERS</b>		
	<b>Customer No.:</b>	<b>24239</b>	

## FACSIMILE TRANSMISSION CERTIFICATE

**Attn: Examiner Shamim Ahmed**

**Fax No. (571) 273-8300**

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450, on April 20, 2006, to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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**Lillian Glenn**

**April 20, 2006**

Date \_\_\_\_\_

**SUBMISSION OF POWER OF ATTORNEY AND STATEMENT UNDER 37 CFR 3.73(b)  
AND AMENDMENT RESPONDING TO MARCH 21, 2006 OFFICE ACTION IN  
UNITED STATES PATENT APPLICATION NO. 10/807,858**

**Mail Stop Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450**

Sir:

**This responds to the March 21, 2006 Office Action in the above-identified application.**

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Please amend the claims of the application as set out in the following **Section I (Amendments to the Claims)**.

Remarks addressing the substance of the March 21, 2006 Office Action are set out in the **Section II (Remarks)** hereof.